INFORMATION DISCLOSURE \3 STATEMENT BY Sheet 1 of 1

Filing Date:

10/646,526

August 22, 2003

First Named Inventor:

Application Number:

Kenneth COLLINS, et al.

Group Art Unit:

1763

Examiner Name:

Maureen G. Arancibia

Attorney Docket Number:

006915 P08

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Examiner's Signature: Marrier & armer

Date Considered: 03/02/2006

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION FEB 1 3 7 STATEMENT BY PPLICA

Sheet 1 of 1.

Application Number:

10/646,526

Filing Date:

08/22/2003

First Named Inventor:

Kenneth COLLINS, et al.

Group Art Unit:

1763

Examiner Name:

Maureen G. Arancibia

Attorney Docket Number: 006915/P08

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Examiner's Signature: Maureen Maranari

MOT

Date Considered: 03/02/2006

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